

IN THE SPECIFICATION

Please enter the following amendment to the Specification:

Please amend paragraph 0038 to read as follows:

[0038] The second image sensor 136-236 may be configured or made of materials to detect different wavelengths than the first image sensor 130-230. For example, the first image sensor 130-230 may have detector materials to detect light in the near infrared (NIR) or medium-wave infrared (MWIR) ranges while the second image sensor 136-230 may be made from detector material(s) sensitive to visible light. For example, in certain embodiments, the second image sensor 136-236 may have peak detectivity near 700 nm. Semiconductor detector materials for the first and second image sensors 130-136-230, 236 may be selected based on bandgap energies and corresponding detection capabilities.